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# Contents

## Foreword

## Preface

### Chapter 1 Fundamentals of vacuum science and technology 1

- 1.1 Properties of vacuum 1
- 1.2 The kinetic theory model of a vacuum 2
- 1.3 Flow of gas through vacuum systems 5
- 1.4 Pumping of vacuum systems 9
- 1.5 Sources of gas within the vacuum system 12
- 1.6 References 21

### Chapter 2 Materials for ultrahigh vacuum 22

- 2.1 Criteria for ultrahigh vacuum materials 22
- 2.2 Glass 23
- 2.3 Metals 33
- 2.4 Ceramics 46
- 2.5 Other materials 51
- 2.6 Fabricating techniques 56
- 2.7 References 67

### Chapter 3 Pumps 69

- 3.1 Background 69
- 3.2 Diffusion pumps 70
- 3.3 Turbomolecular pumps 77
- 3.4 Sorption pumps 84
- 3.5 Cryogenic pumps 92
- 3.6 Sublimation and getter pumps 99
- 3.7 Ion pumps 106
- 3.8 Choice of pumps 118
- 3.9 References 122

### Chapter 4 Total pressure measurements 124

- 4.1 Introduction 124
- 4.2 Ionization gauges 125
- 4.3 Momentum transfer gauges 148
- 4.4 Gauge calibration 153
- 4.5 References 158

<b>Chapter 5</b>	<b>Partial pressure measurements</b>	<b>160</b>
5.1	The need for partial pressure gauges	160
5.2	Gauge parameters	162
5.3	Ion sources	165
5.4	Static spectrometers	167
5.5	Dynamic spectrometers	175
5.6	Ion detection	192
5.7	Calibration and performance	198
5.8	References	202
<b>Chapter 6</b>	<b>Ultrahigh vacuum line components</b>	<b>204</b>
6.1	Scope	204
6.2	Demountable seals	205
6.3	Mechanical feed-throughs and dynamic seals	210
6.4	Valves	216
6.5	Other vacuum line components	223
6.6	Liquid nitrogen replenisher	225
6.7	References	227
<b>Chapter 7</b>	<b>Systems and applications</b>	<b>228</b>
7.1	Introduction	228
7.2	Systems requirements	228
7.3	Basic pumping considerations	230
7.4	Approaches to system design	235
7.5	Applications	244
7.6	References	256
<b>Chapter 8</b>	<b>Leak detection</b>	<b>258</b>
8.1	Basic techniques	258
8.2	Performance requirements	259
8.3	Leak detecting with an ion gauge	264
8.4	Leak detecting with an ion pump	266
8.5	The halogen leak detector	266
8.6	The mass spectrometer leak detector	268
8.7	Calibration of mass spectrometer leak detectors	271
8.8	References	274
<b>Appendix 1</b>	<b>Derivation of kinetic theory equations</b>	<b>275</b>
A1.1	Pressure	275
A1.2	Velocity distribution and mean velocity	276
A1.3	Rate at which molecules are incident on a surface	277
A1.4	Mean free path	278
<b>Appendix 2</b>	<b>Vapour pressure curves of the elements</b>	<b>279</b>
<b>Appendix 3</b>	<b>Conversion tables for vacuum quantities</b>	<b>282</b>
<b>Index</b>		<b>283</b>